

Title (en)
ENGINEERED SUBSTRATE STRUCTURE FOR POWER AND RF APPLICATIONS

Title (de)
MANIPULIERTE SUBSTRATSTRUKTUR FÜR LEISTUNGS- UND HF-ANWENDUNGEN

Title (fr)
STRUCTURE DE SUBSTRAT TECHNIQUE POUR APPLICATIONS DE PUISSANCE ET DE RADIOFRÉQUENCE

Publication
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Application
EP 17813933 A 20170613

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Abstract (en)
[origin: WO2017218536A1] A substrate includes a support structure comprising: a polycrystalline ceramic core; a first adhesion layer coupled to the polycrystalline ceramic core; a conductive layer coupled to the first adhesion layer; a second adhesion layer coupled to the conductive layer; and a barrier layer coupled to the second adhesion layer. The substrate also includes a silicon oxide layer coupled to the support structure, a substantially single crystalline silicon layer coupled to the silicon oxide layer, and an epitaxial III-V layer coupled to the substantially single crystalline silicon layer.

IPC 8 full level
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Citation (search report)
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WO 2017218536 A1 20171221; CN 109844184 A 20190604; CN 109844184 B 20211130; CN 114256068 A 20220329; EP 3469119 A1 20190417; EP 3469119 A4 20200226; JP 2019523994 A 20190829; JP 2020074399 A 20200514; JP 2022058405 A 20220412; JP 2023182643 A 20231226; JP 6626607 B2 20191225; JP 7001660 B2 20220119; JP 7416556 B2 20240117; KR 102361057 B1 20220208; KR 20190019122 A 20190226; SG 11201810919U A 20190130; TW 201807839 A 20180301; TW 202203473 A 20220116; TW 202322418 A 20230601; TW 202429726 A 20240716; TW I743136 B 20211021; TW I793755 B 20230221; TW I839076 B 20240411

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